

PATENT ASSIGNMENT COVER SHEET

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EPAS ID: PAT4341536

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
TOSHIYUKI MAENOSONO	03/13/2017
YUTA KIKUCHI	03/09/2017
MANABU ITO	03/10/2017
YOSHIHIRO SAEKI	03/27/2017
RECEIVING PARTY DATA	
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PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	15472184
CORRESPONDENCE DATA	
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ATTORNEY DOCKET NUMBER:	P260427.US.01
NAME OF SUBMITTER:	MIKA ITO
SIGNATURE:	/Mika Ito/
DATE SIGNED:	03/28/2017
Total Attachments: 4	
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Toshiyuki Maenosono, Yuta Kikuchi,
Manabu Ito and Yoshihiro Saeki

Docket No. P260427.US.01

Disclosure No. 2015-0092.00/US

Filed : Concurrently herewith

For : METHOD OF FORMING VIAS
USING SILICON ON INSULATOR
SUBSTRATE

ASSIGNMENT :

X Enclosed for recording

Previously recorded

Date: _____

Reel: _____

FOR GOOD AND VALUABLE CONSIDERATION, the receipt, sufficiency and adequacy of which are hereby acknowledged, the undersigned do hereby:

SELL, ASSIGN AND TRANSFER to **Micron Technology, Inc.** (the "Assignee"), a corporation of Delaware, having a place of business at 8000 South Federal Way, Boise, Idaho 83716-9632, the entire right, title and interest for the United States and all foreign countries, in and to any and all improvements which are disclosed in the application for United States Letters Patent, which has been executed by the undersigned concurrently herewith and is entitled "**METHOD OF FORMING VIAS USING SILICON ON INSULATOR SUBSTRATE** "; such application and all divisional, continuing, substitute, renewal, reissue and all other applications for patent which have been or shall be filed in the United States and all foreign countries on any of such improvements; all original and reissued patents which have been or shall be issued in the United States and all foreign countries on such improvements; and specifically including the right to file foreign applications under the provisions of any convention or treaty and claim priority based on such application in the United States of America;

AUTHORIZE AND REQUEST the issuing authority to issue any and all United States and foreign patents granted on such improvements to the Assignee;

WARRANT AND COVENANT that no assignment, grant, mortgage, license or other agreement affecting the rights and property herein conveyed has been or will be made to

others by the undersigned, and that the full right to convey the same as herein expressed is possessed by the undersigned;

COVENANT that, when requested and at the expense of the Assignee, to carry out in good faith the intent and purpose of this assignment, the undersigned will execute all divisional, continuing, substitute, renewal, reissue, and all other patent applications on any and all such improvements; execute all rightful oaths, declarations, assignments, powers of attorney and other papers; communicate to the Assignee all facts known to the undersigned relating to such improvements and the history thereof; and generally do everything possible which the Assignee shall consider desirable for securing, maintaining and enforcing proper patent protection for such improvements and for vesting title to such improvements in the Assignee;

TO BE BINDING on the heirs, assigns, representatives and successors of the undersigned and extend to the successors, assigns and nominees of the Assignee.

Signature: Toshiyuki Maenosono Date: 2017.3.13
(YYYY-MM-DD)
Assignor Name: Toshiyuki Maenosono

Witness 1:
Signature: Toshiyuki Hirota Date: 2017.3.13
(YYYY-MM-DD)
Witness Name: Toshiyuki Hirota

Witness 2:
Signature: Shoko Tomita Date: 2017-03-13
(YYYY-MM-DD)
Witness Name: Shoko Tomita

Docket No. P260427.US.01

Signature: Yuta Kikuchi

Date: 2017.3.9
(YYYY-MM-DD)

Assignor Name: Yuta Kikuchi

Witness 1:

Signature: Toshiyuki Hirota

Date: 2017.3.9
(YYYY-MM-DD)

Witness Name: Toshiyuki Hirota

Witness 2:

Signature: Shoko Tomita

Date: 2017-03-09
(YYYY-MM-DD)

Witness Name: Shoko Tomita

Signature: Manabu Ito

Date: 2017.3.10
(YYYY-MM-DD)

Assignor Name: Manabu Ito

Witness 1:

Signature: Toshiyuki Hirota

Date: 2017.3.10
(YYYY-MM-DD)

Witness Name: Toshiyuki Hirota

Witness 2:

Signature: Shoko Tomita

Date: 2017-03-10
(YYYY-MM-DD)

Witness Name: Shoko Tomita

Signature: Yoshihiro Sacki

Date: 2017-03-27
(YYYY-MM-DD)

Assignor Name: Yoshihiro Sacki

Witness 1:

Signature: Toshiyuki Hirota

Date: 2017-03-27
(YYYY-MM-DD)

Witness Name: Toshiyuki Hirota

Witness 2:

Signature: Shoko Tomita

Date: 2017-03-27
(YYYY-MM-DD)

Witness Name: Shoko Tomita